

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Yasushi ISAYAMA et al. :
Serial No. NEW : **Attn: APPLICATION BRANCH**
Filed July 28, 2003 : Attorney Docket No. 2003-1051
METHOD OF MEASURING THE :
CONCENTRATION OF A LEVELER IN
A PLATING LIQUID, AND METHOD OF
AND APPARATUS FOR MANAGING A
PLATING LIQUID
(Rule 1.53(b) Divisional of Serial No.
09/830,407, Filed April 27, 2001)

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

CLAIM OF PRIORITY UNDER 35 USC 119

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

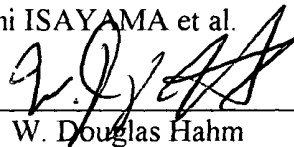
Applicants in the above-entitled application hereby claim the date of priority under the International Convention of Japanese Patent Application No. 11-243441, filed August 30, 1999, and Japanese Patent Application No. 11-244582, filed August 31, 1999, as acknowledged in the Declaration of this application.

A certified copy of said Japanese Patent Applications are of record in parent application Serial No. 09/830,407, filed April 27, 2003.

Respectfully submitted,

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By



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